

**Search Notes**

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10/611,625

Examiner

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Applicant(s)/Patent under  
Reexamination

JAYASEKARA, WIPUL

Art Unit

3729

**SEARCHED**

Class	Subclass	Date	Examiner
29	603.08 603.11 603.13- 603.16	11/21/2005 ↓	PK
	603.18	↓	
360	324.2 324.12	11/21/2005 ↓	PK
	121 122 126	↓	

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application 09/848,674 US PAT. 6,833,982	11/21/2005	PK
Text Search EAST/NPL (IEEE)	11/22/2005	PK